



**PATENT APPLICATION** IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Sadayoshi HORII et al.

ATTN: Application Branch

Application No.: 10/529,466

Docket No.: 123373

Filed: May 2, 2005

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND  
SUBSTRATE PROCESSING APPARATUS

**CORRECTED FILING RECEIPT STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The above-identified application satisfied the requirements of 35 U.S.C. §371 on May 2, 2005, and was accorded U.S. Serial No. 10/529,466. Applicants filed a Request for Correction of PALM Records on October 17, 2005 to reflect the May 2, 2005 §371(c) date. However, Applicants to date have not received a Corrected Official Filing Receipt.

Applicants hereby request that a Corrected Official Filing Receipt be promptly forwarded to Applicants' representative.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Linda M. Saltiel  
Registration No. 51,122

JAO:LSM/phd

Date: April 17, 2006

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**